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## AUG 16 2006

S/N 10/682229

**PATENT** 

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:

**TABARA** 

Examiner:

G. Goudreau

Serial No .:

10/682229

Group Art Unit:

Name: Gina M. Dahl

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Filed:

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Title:

METHOD OF MANUFACTURING SEMICONDUCTOR DEVICE

CERTIFICATE UNDER 37 CFR 1.6(d); I hereby certify that this paper is being transmitted by facsimile to the U.S. Patent and Trademark Office on August 10

2006.

## CHANGE OF CORRESPONDENCE ADDRESS

Commissioner for Patents P.O. Box 1450 Alexandria, Virginia 22313-1450

Dear Sir:

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PATENT TRADEMARK OFFICE

Respectfully submitted,

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Dated: August 16 2006

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